



#15/C
9/15/03
PATENT *Mallish*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Ko et al.

Serial No.: 09/585,682 ✓

Filed: June 1, 2000 ✓

**For: SEMICONDUCTOR DEVICE
HAVING A SUBSTRATE, AN UNDOPE
SILICON OXIDE STRUCTURE, AND AN
OVERLYING DOPED SILICON OXIDE
STRUCTURE WITH A SIDEWALL
TERMINATING AT THE UNDOPE
SILICON OXIDE STRUCTURE (Amended)**

Confirmation No.: 7481

Examiner: C. Chu

Group Art Unit: 2815

Attorney Docket No.: 2269-3526.2US
(97-1136.02/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

August 29, 2003
Date

[Signature]
Signature

Deidra J. Pfeil
Name (Type/Print)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Office Action mailed on May 30, 2003, the three-month shortened statutory period for response to which expires on Tuesday, September 2, 2003, since August 30, 2003, falls on a Saturday and Monday, September 1, 2003, is a federal holiday. 37 C.F.R. § 1.7.

Amendments to the claims are set forth in the listing of the claims, which starts at page 2 of this paper; and

Remarks begin at page 5 of this paper.

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